## IAP9 Rec'd PCT/PTO 02 DEC 2005

## THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	)
Eric Oden et al.	) Group:
Serial No.:	)
Filed: December 2, 2005	)
Title: METHOD AND APPARATUS FOR	) Examiner:
MEASURING A DEPTH OF HOLES IN	)
COMPOSITE-MATERIAL WORKPIECES	)
BEING MACHINED BY AN ORBITING	)
CUTTING TOOL	)

## **PRELIMINARY AMENDMENT**

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please enter the following Amendment to the application prior to calculating the filing fee.

The following sections are included herewith:

- Amendments To The Claims
- Amendments To The Specification
- Amendments To The Drawings
- Amendments To The Abstract
- Remarks